

Inventor Information

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Application Information

Title Line One::	METHOD FOR PRODUCING SOI WAFER AND
Title Line Two::	SOI WAFER
Total Drawing Sheets::	4
Docket Number::	109725

Continuity Information

>This application is a:: 371 of
Application One:: PCT/JP00/07111
Filing Date:: October 13, 2000

Prior Foreign Applications

Foreign Application One:: 11-292134
Filing Date:: October 14, 1999
Country:: Japan
Priority Claimed:: yes

Assignee Information

Name of assignee:: SHIN-ETSU HANDOTAI CO., LTD.
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